



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of .

Docket No: Q62494

Ryo KUBOTO, et al.

Appln. No.: 09/817,233

Group Art Unit: 2823

Confirmation No.: 8072

Examiner: Hsien Ming LEE

Filed: March 27, 2001

For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE HAVING DRAM
CAPACITORS

STATEMENT UNDER 37 C.F.R. § 1.97(e)

Commissioner for Patents
Washington, D.C. 20231

Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed
concurrently herewith was first cited in any communication from a foreign patent office in a counterpart
foreign application not more than three months prior to the filing of said Information Disclosure
Statement.

Respectfully submitted,

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WASHINGTON OFFICE



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PATENT TRADEMARK OFFICE

Date: APR 15 2003

